

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) END9200001-61	Application Number <b>09/819 457</b>			
				Applicant(s) <b>David J. Alcoe et al.</b>				
				Filing Date <b>03-28-01</b>	Group Art Unit <b>2813</b>			
<b>U.S. PATENT DOCUMENTS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
		5,316,803	5/31/94	White, Jr. et al.	427/554		12/10/92	
		5,536,579	7/16/96	Davis et al.	428/421		6/02/94	
		5,560,840	10/01/96	Covert et al.	216/108		12/19/94	
		5,626,771	5/06/97	Davis et al.	216/13		6/06/95	
		5,672,548	9/30/97	Culnane et al.	437/209		6/26/96	
		5,723,062	3/03/98	Covert et al.	252/79.2		5/28/96	
		5,726,863	3/10/98	Nakayama et al.	361/794		1/25/96	
		5,798,563	8/25/98	Feilchenfeld et al.	257/668		8/25/98	
		5,847,935	12/08/98	Thaler et al.	361/761		12/16/96	
		5,877,550	3/02/99	Suzuki	257/700		7/16/97	
		5,886,406	3/23/99	Bhansali	257/698		10/07/97	
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
<i>J. M. H.</i>		MULTILAYER SUBSTRATE WITH LOW COEFFICIENT OF THERMAL EXPANSION, Nakamura et al., 2000 International Symposium on Microelect, pages 235-240.						
EXAMINER	<i>J. M. H.</i>			DATE CONSIDERED	<i>5/6/02</i>			

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JW		5,926,377	7/20/99	Nakao et al.	361/763		11/17/97
		5,989,443	11/23/99	Covert et al.	216/13		10/03/99
		6,006,428	12/28/99	Feilchenfeld et al	29/852		4/01/98
		6,054,758	4/25/00	Lamson	257/691		12/16/97
		6,090,633	7/18/00	Yu et al.	438/15		9/22/99
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER <i>Jeanne M. Miller</i>				DATE CONSIDERED <i>3/6/02</i>			
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